

LAYER

Stool type
Bench type



LAYER

TAFNEX™ by MITSUI CHEMICALS, INC. × JUNICHIRO YOKOTA STUDIO

The material used in exhibition is TAFNEX™ end chips generated in its production process. Those chips are usually treated as industrial wastes and discarded, but once integrated into a singular material form TAFNEX™.

The benches and stools on display are designed to embody this characteristic. Composed of two overlapping upper and lower sections, each individual part has a shape that cannot stand on its own. Only once combined do these two imperfect parts form a complete product.

Design : [JUICHIRO YOKOTA STUDIO](#)

Production : [ARRK](#)

TAFNEX™ sheet Production : [SUNCORONA ODA](#)



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